"Express Mail" Label No. EV 326934290US
Date of Deposit September 8, 2003

I hereby certify that this is being deposited with the United States Postal Service "Express Mail Post Office to Address" service under 37 CFR 1.10 on the date indicated above and is addressed to: Attorney Docket No. A4356/T035310
AMAT No. 4356
USA/D01/DSM/HDP/CVD/JW
TTC No. 016301-035310US

Mail Stop Patent Application Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Tetsuya Ishikawa et al.

Application No.: Not yet assigned

Filed: Not yet assigned

For: METHOD OF REDUCING PLASMA CHARGE DAMAGE FOR

PLASMA PROCESSES

Examiner: Not yet assigned

Technology Center/Art Unit: Not yet

assigned

PRELIMINARY AMENDMENT

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please enter the

following amendments and remarks:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 7 of this paper.